

Providing favorable conditions for inline monitoring of Ceria slurry quality in Slurry Delivery Systems



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Public reports on colloidal silica slurry dilution and blending adopting inline refractive index measurement technology



Article

Characterization of CMP Slurries Using Densitometry and Refractive Index Measurements

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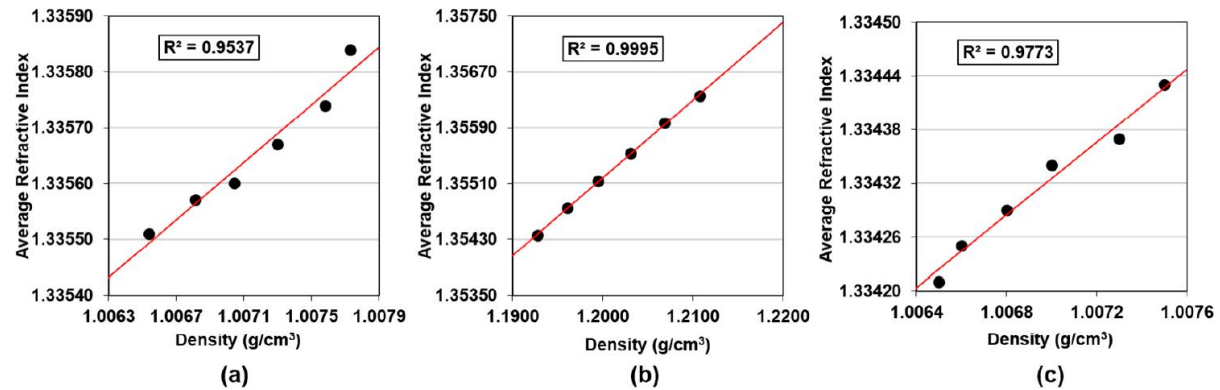


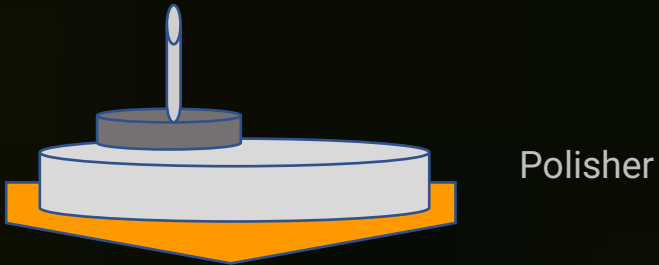
Figure 5. Correlation between density and average refractive index for (a) Fujimi PL-7106; (b) Klebosol 1501-50; and (c) CMC W7801.

Table 2. Calculation of the approximate minimum detectable change in UPW concentration.

Slurry Instrument	Fujimi PL-7106		Klebosol 1501-50		CMC W7801	
	Densitometry	Refractive Index	Densitometry	Refractive Index	Densitometry	Refractive Index
Slope ($\frac{1}{\%UPW}$)	$1.33 \times 10^{-4} \frac{g}{cm^3}$	3.52×10^{-5}	$1.98 \times 10^{-3} \frac{g}{cm^3}$	2.21×10^{-4}	$1.15 \times 10^{-4} \frac{g}{cm^3}$	2.37×10^{-5}
Approximate LOD (% UPW)	0.752	0.284	0.050	0.045	0.870	0.422



Typical elements in a Slurry Delivery System



Polisher



Concentration monitor (refractive index)



UPW/Additive/H2O2 depending on application

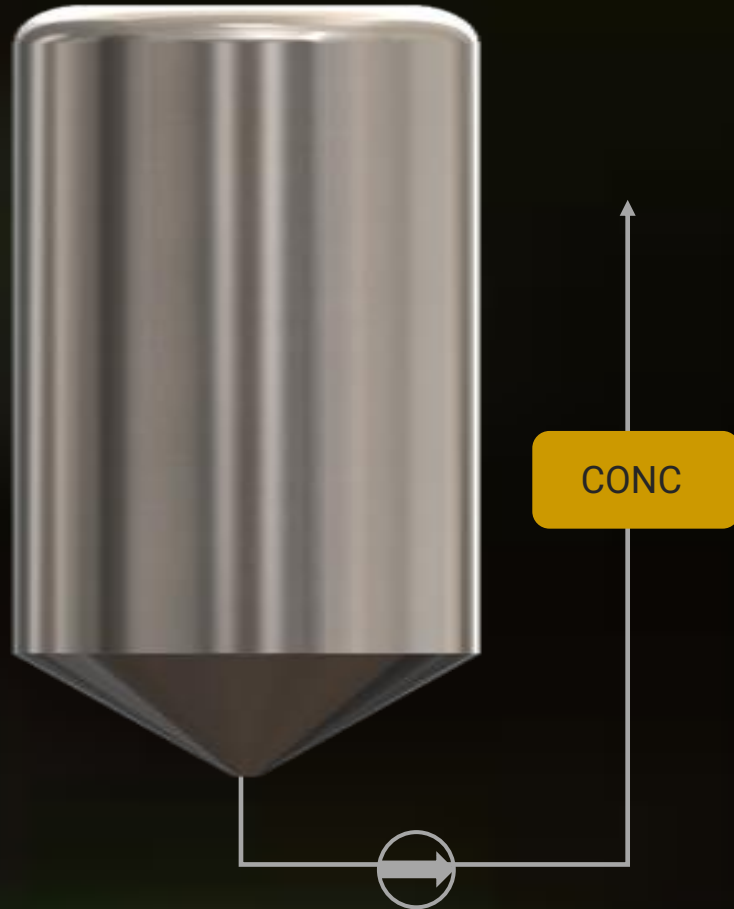


Slurry

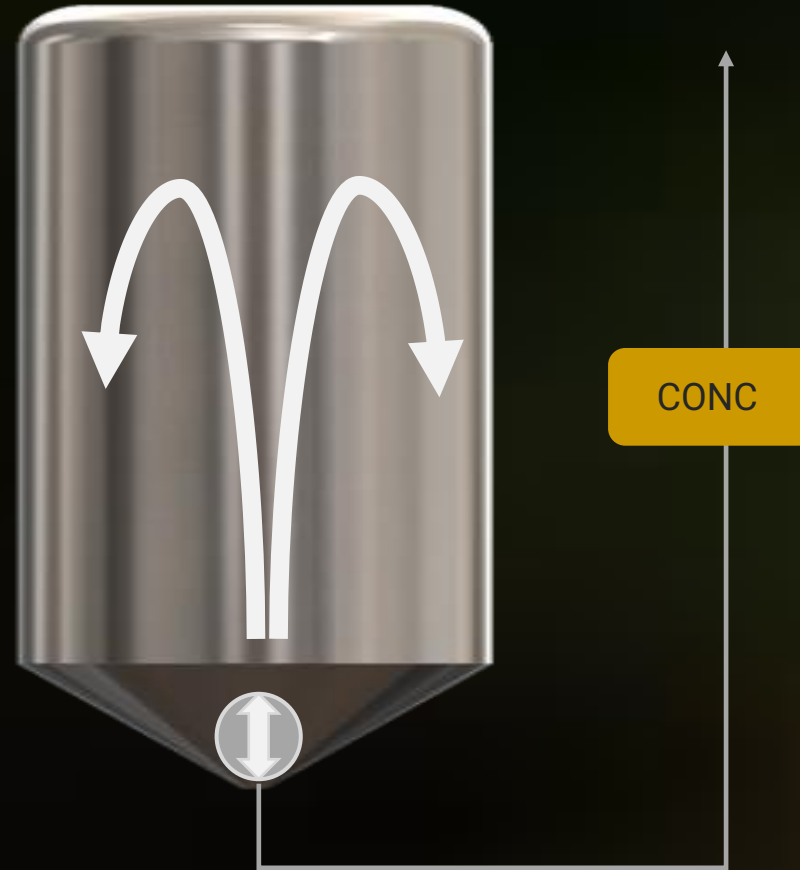


Ensure well dispersed Ceria slurry

Problem



Solution



Design rules

Our recommended design rules to ensure uniform Ceria slurry quality:

1. Ensure sufficient mixing and flowrate in all tanks and lines where Ceria slurry is present.
2. Pump tank mixer and conical shape tank combination has been proven to work.
3. Inner surface of tank should be as smooth as possible.
4. Ensure balanced slurry flowrate at every branch of the slurry delivery loop.
5. Minimize number of valves with correct flow calculations or simulations to avoid slurry agglomeration in slurry loops.
6. Good premixing of drum with suppliers recommended mixer.

Design rules

- Before upgrading our slurry system with above mentioned design rules the inline refractometer slurry concentration measurement was not stable.
- We also experienced variation in polishing removal rate. After upgrade work the polishing removal rate variation has decreased.
- We have also achieved cost savings in ceria slurry consumption by changing the design of drum station. We prefer to first premix the slurry drum and then transfer it with barrel pump to fixed conical shaped delivery tank.
- In fixed slurry delivery tank, we use a pump tank mixer to mix and deliver slurry. This way we can utilize full volume of transferred slurry to the delivery tank where it also remains well dispersed.
- Annual slurry cost savings from these improvements is estimated to 5-10%.

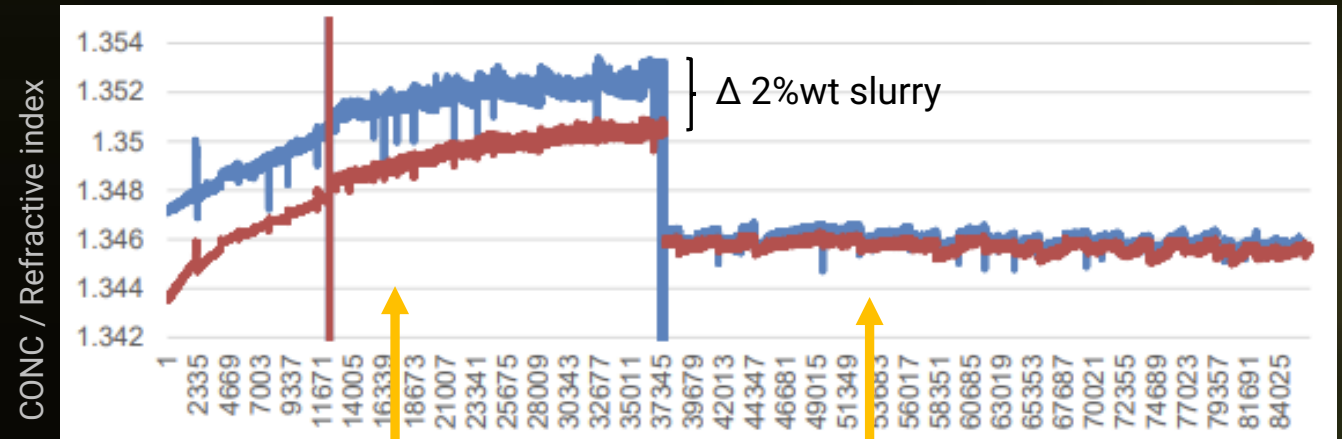
Before and after

Return from supply loop



— Ceria slurry out to CMP loop

— Ceria return from supply loop

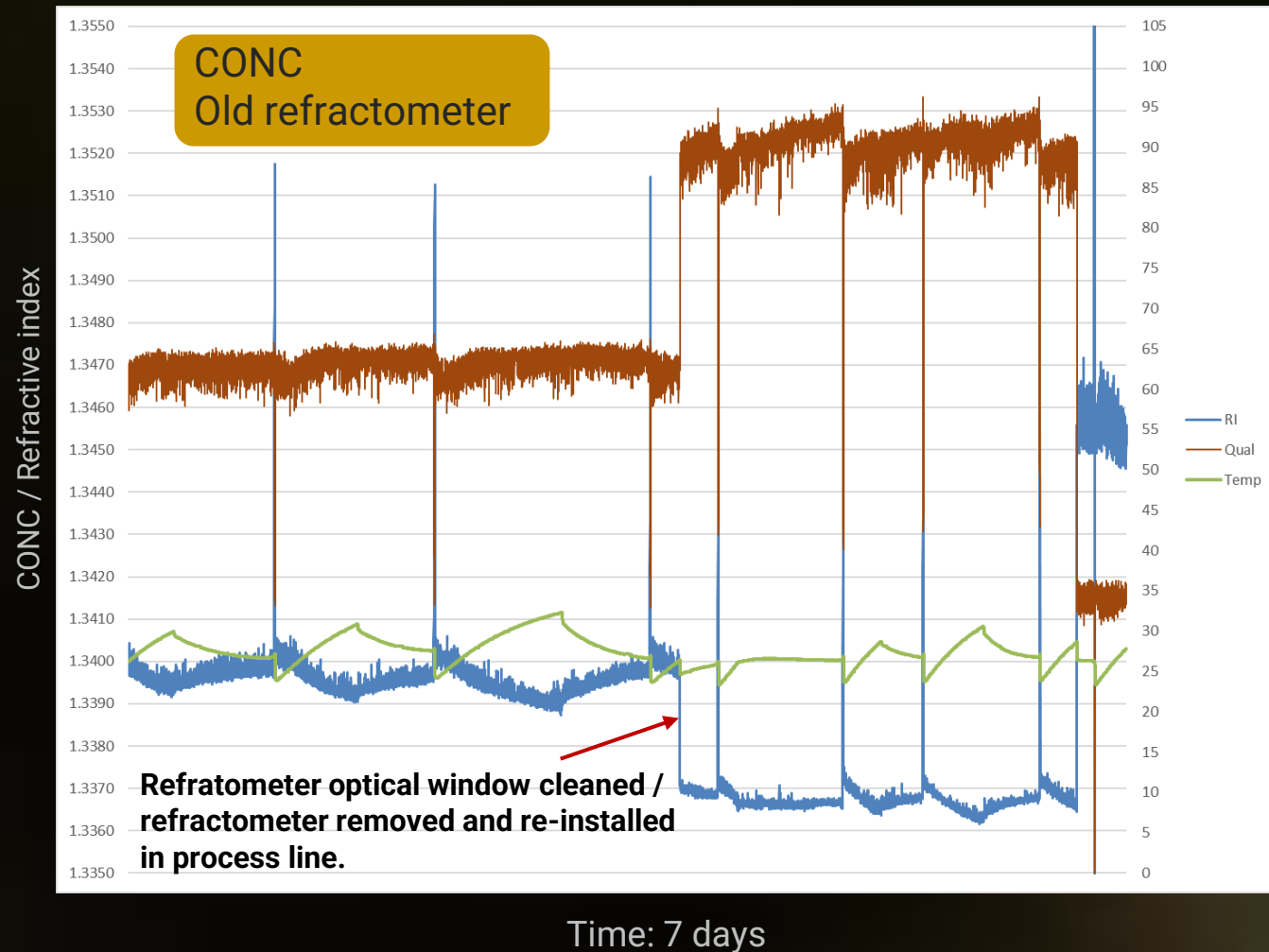


Previous system
without pump-tank-mixer

New conical tank system
with pump-tank-mixer

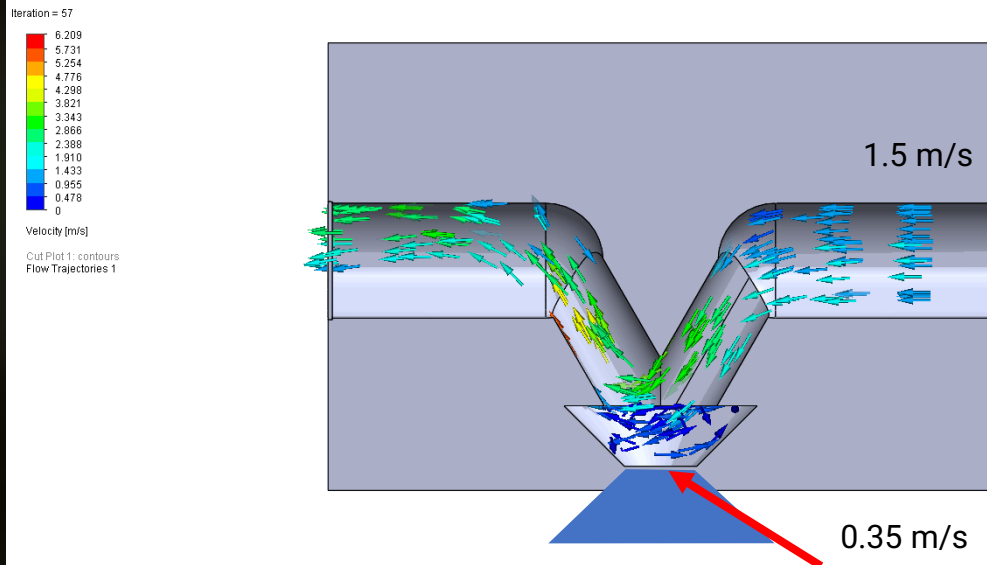
Further obstacles

- Start-up of inline refractometer with old design of sensor internal flow path.
- Output signal from concentration monitor not repeatable.
- Significant RI level changes after removing and reinstalling old refractometer in process line.

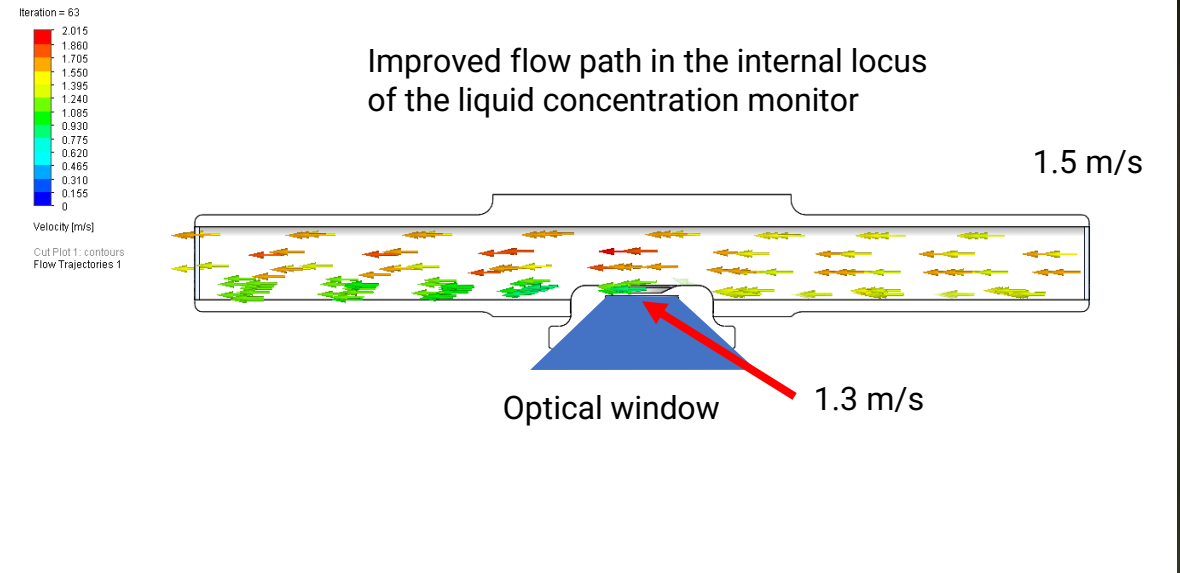


From innovation to solution in 2021

Old refractometer



New refractometer



Normal Operation

CMP-Slurry Concentration

1.02% H₂O₂

CMP-Slurry Temperature

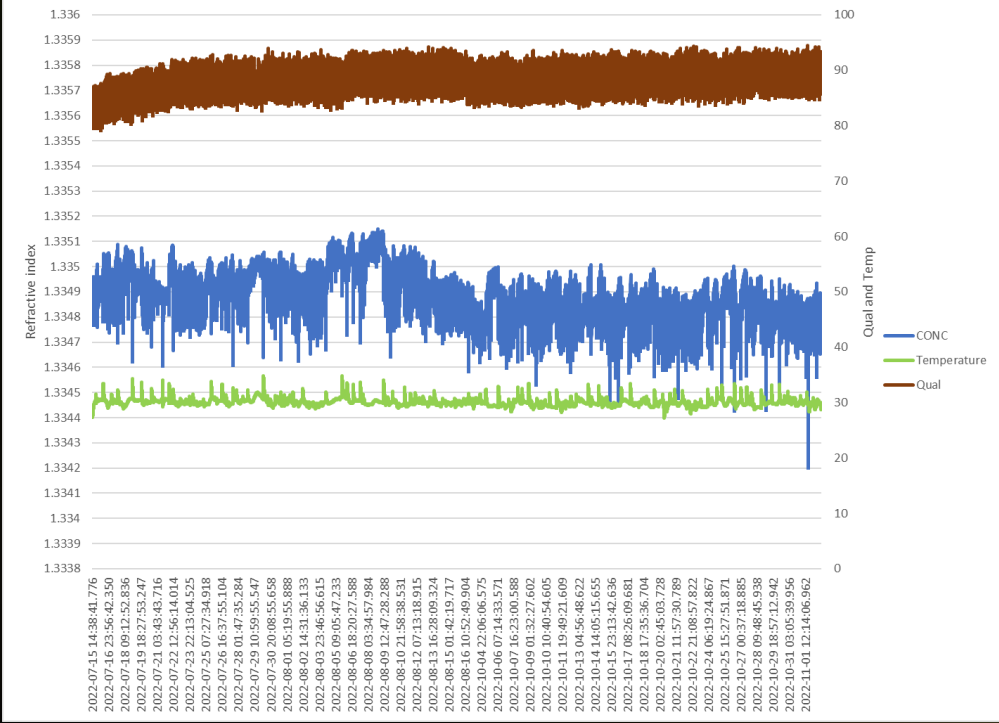
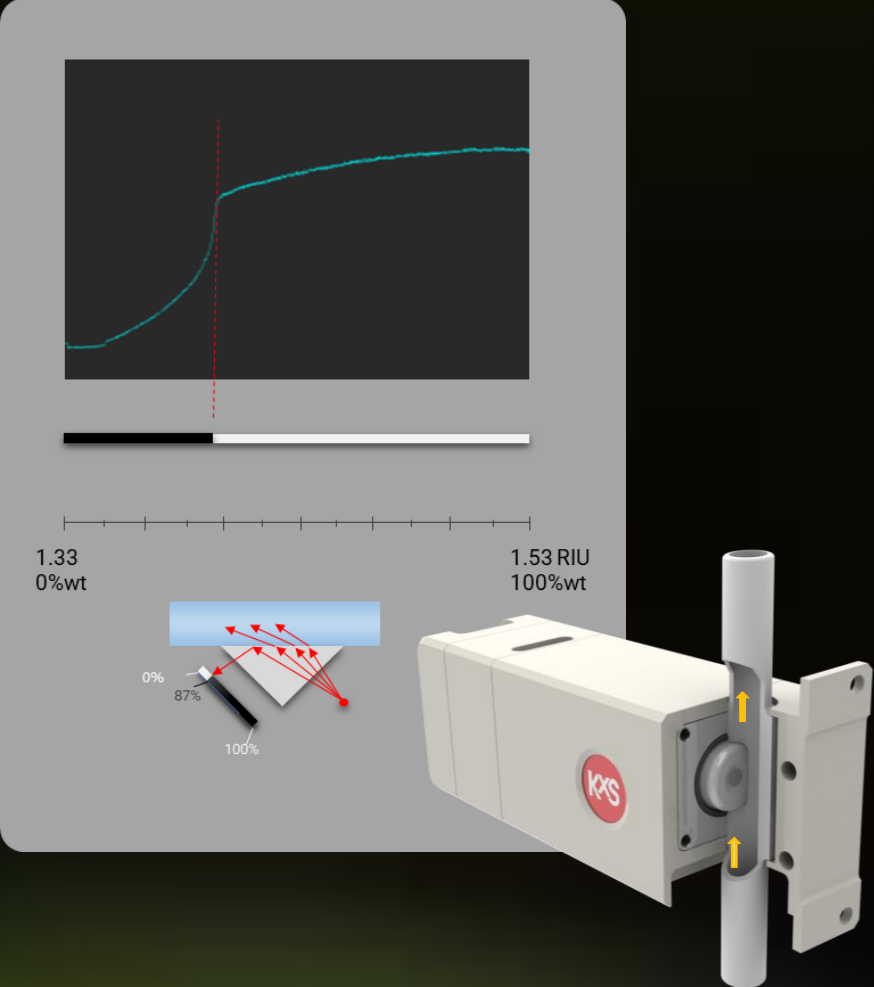
26.12°C



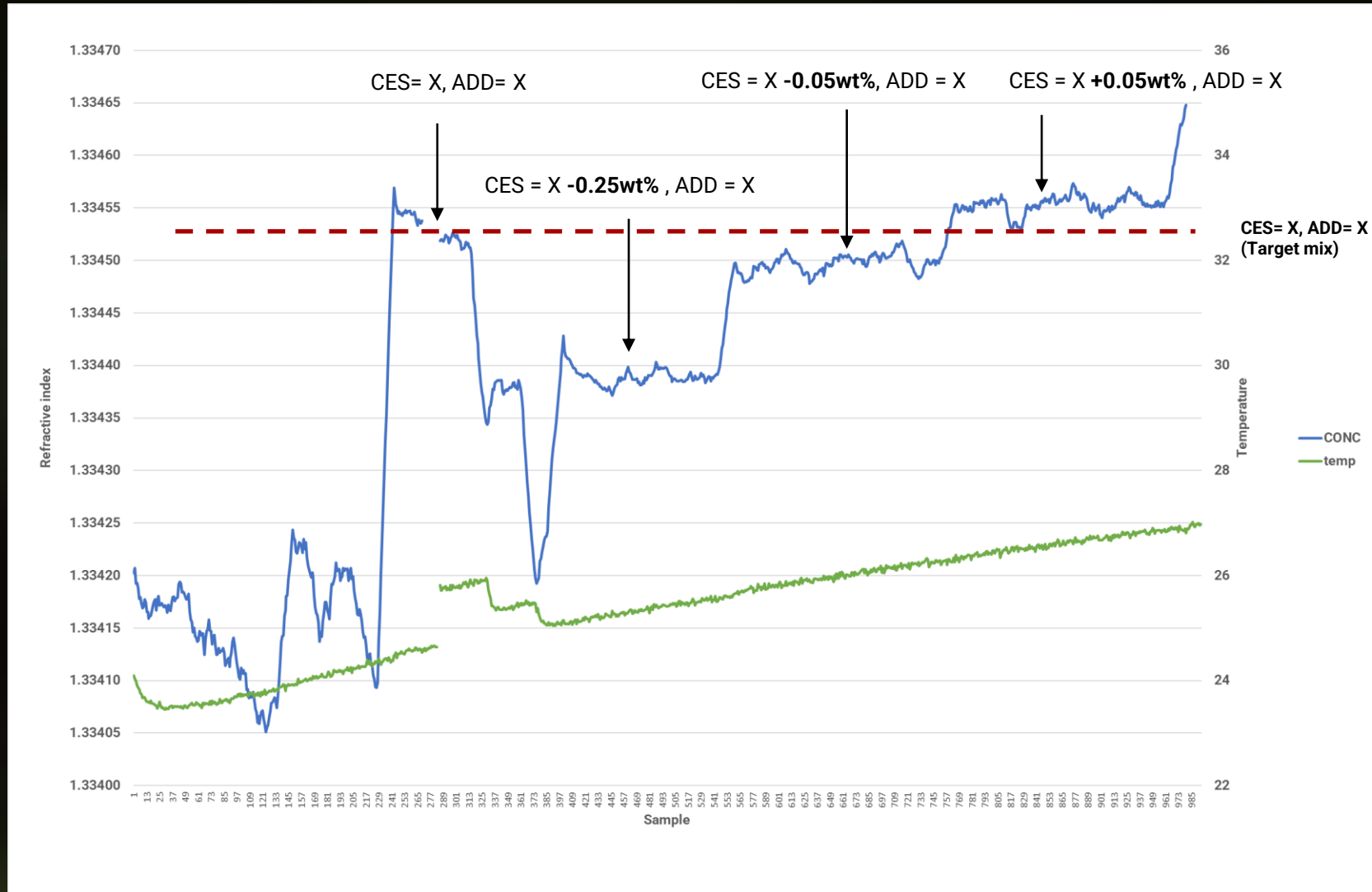
**The Next generation
Inline Concentration Monitor**



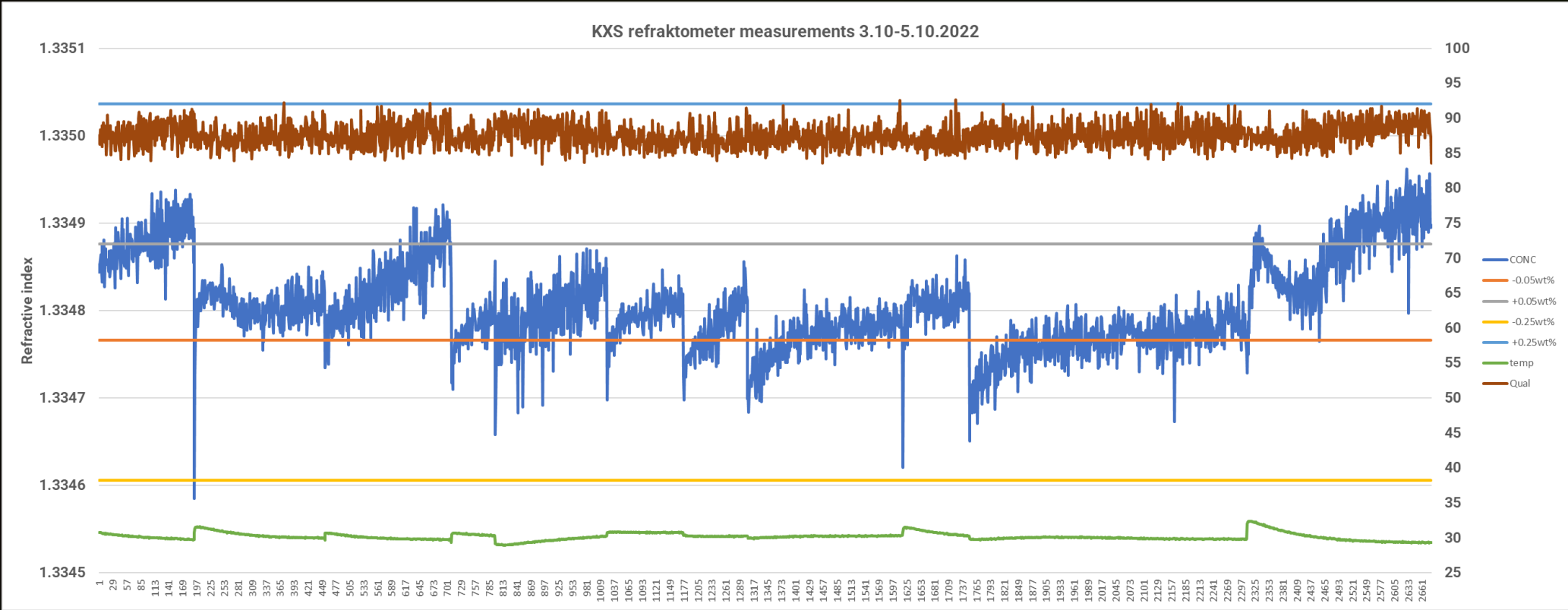
Improved liquid flow path and optical image detection algorithm yields a stable refractive index measurement quality



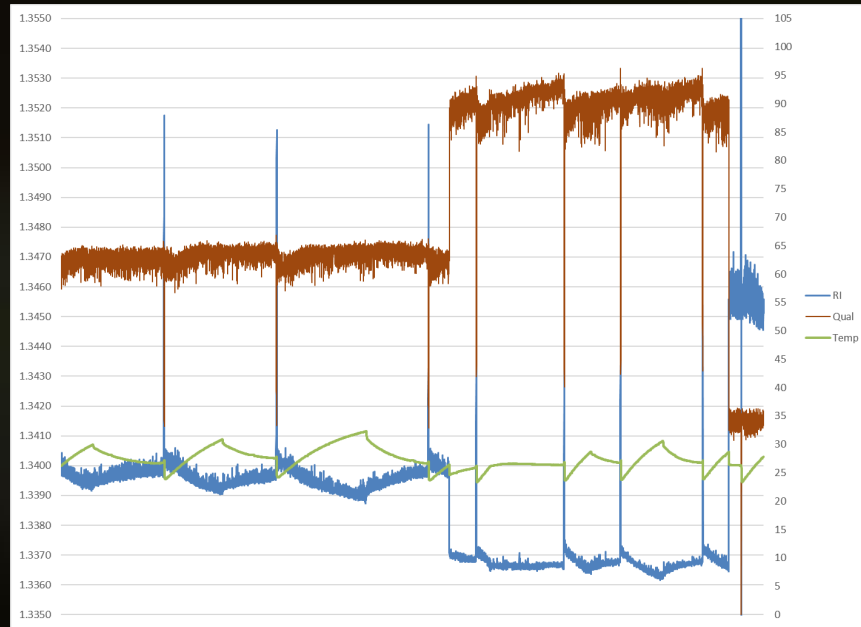
Smallest detectable change



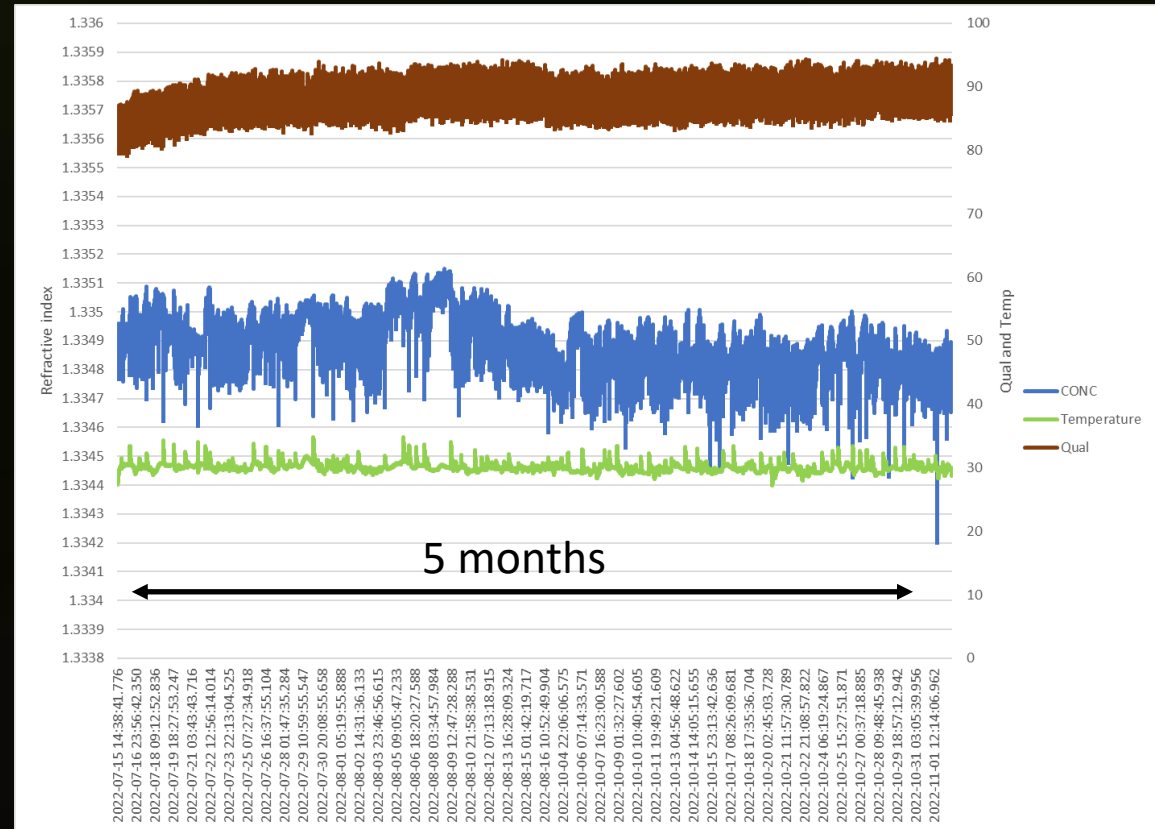
Zoom of consecutive batches



New concentration monitor in service for five (5) months



Old refractometer:
Measurement not repeatable



New refractometer with improved liquid flow path:
Data representing 5 months - Nov 2, 2022

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